

11/19/01
JC839 U.S. PTO

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
REQUEST FOR FILING APPLICATION UNDER 37 C.F.R. 1.53(b)
WITHOUT FILING FEE AND/OR WITHOUT EXECUTED INVENTOR'S DECLARATION

JC979 U.S. PTO
09/988221
11/19/01

Assistant Commissioner for Patents
Washington, DC 20231

Atty. Dkt. 900-408

Date: November 19, 2001

Sir:

This is a request for filing a new PATENT APPLICATION under Rule 53(b) entitled:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

without a filing fee and/or without an executed inventor's oath/declaration.

This application is made by the below identified inventor(s). Attached hereto are the following papers:

☐ Newly executed Declaration, ☐ Copy of Declaration from prior application, ☒ Abstract

26 pages of specification and claims (including 7 numbered claims), and

8 sheets of accompanying drawing/s.

☐ Record the attached assignment and return to the undersigned.

☐ Attached is a Power of Attorney.

☒ Priority is hereby claimed under 35 U.S.C. § 119 based on the following foreign applications:

Application Number

Country

Day/Month/Year Filed

2000-354213

Japan

21 November 2000

☐ , respectively, the entire content of which is hereby incorporated by reference in this application..

☒ Certified copy(ies) of foreign application(s) is/are attached.

☐ Certified copy(ies) filed on _____ in prior application no. _____ filed _____

☐ It is hereby requested that the Examiner consider the art cited in the above parent application(s) by applicant and/or the Examiner for the reasons stated therein. A listing of that art is attached, but pursuant to Rule 98(d) copies are not required.

☐ Applicant claims "small entity" status. ☐ "Small entity" statement attached.

☐ Please enter the attached and/or below preliminary amendment **prior** to calculation of filing fee:

☒ Also attached: ☒ Information Disclosure Statement; ☐ Non-Publication Request; ☐ Nucleotide and/or Amino Acid Sequence Submission; ☐ Statement deleting Inventor(s) named in prior application; ☐ Other:

1. Inventor: Kazuhiro MI HIROHAMA Japan
(first) (last) (citizenship)
Residence: (city) Hiroshima (state/country) Japan
Mailing Address: 1-25-12-102, Hikino-cho, Fukuyama-shi, Hiroshima, Japan
(Zip Code) 721-0942

2. Inventor: Takeshi MI UMEMOTO Japan
(first) (last) (citizenship)
Residence: (city) Hiroshima (state/country) Japan
Mailing Address: 3-1-25, Kitayoshizu-cho, Fukuyama-shi, Hiroshima, Japan
(Zip Code) 720-0073

☐ See attached sheet(s) for additional inventor(s) information!!

Address all future communications to NIXON & VANDERHYE P.C., 1100 North Glebe Road, 8th Floor, Arlington, VA 22201.

1100 North Glebe Road, 8th Floor
Arlington, Virginia 22201-4714
Telephone: (703) 816-4000
Facsimile: (703) 816-4100
HWB:lmv

NIXON & VANDERHYE P.C.

By Atty: H. Warren Burnam, Jr., Reg. No. 29,366

Signature: _____

H. Warren Burnam, Jr.